

IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED
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Applicant(s): Woo Sik Yoo

Assignee: WaferMasters, Inc.

Title: METHOD OF FORMING AN OXIDE LAYER (As Amended)

Serial No.: 10/085,498

Filing Date: February 26, 2002

Examiner: Jolley, Kirsten

Group Art Unit: 1762

Docket No.: M-11549 US

OFFICIAL

Irvine, California
July 7, 2004COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22213-1450**PETITION FOR EXTENSION OF TIME**

Dear Sir:

Applicant(s) respectfully petition(s) for a 1-month extension of time within which to respond to the Final Office Action mailed by the U.S. Patent and Trademark Office on April 6, 2004, such extension allowing the undersigned until August 6, 2004 to respond.

Please charge the fee of \$55.00 to the undersigned's Deposit Account No. 50-2257.

Please charge any additional fees or credit overpayment to the above-deposit account. If there are any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being sent by facsimile to (703) 872-9306 on July 7, 2004.

Tina Kavanaugh
Tina Kavanaugh

July 7 2004

Respectfully submitted,

David S. Park

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Serial No. 10/123,378

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